



Customer No. 22,852

Attorney Docket No. 04329.2306

in the United States Patent and Trademark Office		
In re Application of:		
Yoshio	Ozawa, et al.	Group Art Unit: 2823
Applica	tion No.: 09/559,757	Examiner: Pham, Thanh V.
Filed:	April 27, 2000	RE RE
]	SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURE THEREOF	RECEIVED  JUN-2 2003  ECHNOLOGY CENTER 2800
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450		R 2800

## RESPONSE TO RESTRICTION REQUIREMENT

In the Restriction Requirement dated May 2, 2003, with a period for response extending through June 2, 2003, the Examiner required restriction under 35 U.S.C. § 121 between two Species. Applicants provisionally elect to prosecute the first Specie, characterized by the Examiner as "wherein the film which must be processed is formed on the insulating film." Applicants submit that claims 8-15 are readable thereon, and note for the record that the Examiner admitted "claim 8 is generic with respect to claim 12" (Restriction Requirement, p. 2).

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

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Sir:

Dated: May 30, 2003

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